

OK TO ENTER: /MS/

07/24/2009

**REPLY UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER 1700
Docket No. 0091.1032**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Ji Yong PARK et al.

Application No. 10/690,507

Group Art Unit: 1792

Confirmation No. 6043

Filed: October 23, 2003

Examiner: Matthew J. Song

For: METHOD FOR MANUFACTURING POLYCRYSTALLINE SILICON THIN FILM AND
THIN FILM TRANSISTOR FABRICATED USING POLYCRYSTALLINE SILICON THIN
FILM MANUFACTURED BY THE MANUFACTURING METHOD

AMENDMENT AFTER APPEAL AND BEFORE FILING OF APPEAL BRIEF

Mail Stop AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Further to the Notice of Appeal and the Pre-Appeal Request for Review filed March 26, 2009, this is in response to the Final Office Action mailed January 26, 2009, and the Notice of Panel Decision from Pre-Appeal Brief Review mailed May 6, 2009, which reset the period for filing an Appeal Brief to expire on June 6, 2009.

The following amendments and remarks are respectfully submitted. Entry of this Amendment After Appeal and Before Filing of Appeal Brief is respectfully requested.

Amendments to the claims are reflected in the listing of the claims that begins on page 2 of this paper.

Remarks begin on page 6 of this paper.